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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yasunori, et al.

Attorney Docket No.: MURTP083D1

Application No.: 10/640,850

Examiner: To Be Assigned

Filed: August 13, 2003

Group: 1755

Title: METHOD OF PRODUCING CERAMIC

THERMISTOR CHIPS

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Alexandria, Virginia 22313-1450 on May 25, 2005.

Signed:

Deborah Neill

# INFORMATION DISCLOSURE STATEMENT 37 CFR §§1.56 AND 1.97(b)

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449 may be material to examination of the above-identified patent application. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. MURTP083D1).

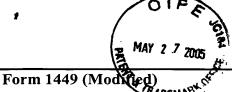
Respectfully submitted,

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Information Disalogue

Information Disclosure Statement By Applicant

Atty Docket No. MURTP083D1

Application No.: 10/640,850

Applicant:

Yasunori Ito, et al.

Filing Date

Group 1755

(Use Several Sheets if Necessary)

August 13, 2003

#### **U.S. Patent Documents**

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•	I	8-321405	12/03/96	Japan				
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	M	Singer, et al., Industrial Ceramics, pp 1199-1200 (1963).
	N	
	0	
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified)	Atty Docket No.	Application No.:
	MURTP083D1	10/640,850
Information Disclosure	Applicant:	
Statement By Applicant	Yasunori Ito, et al.	
	Filing Date	Group
(Use Several Sheets if Necessary)	August 13, 2003	1755

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Initial	No.	No.	Date	Patent Office	Class	class	Yes	No
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### **Other Documents**

No.	Author, Title, Date, Place (e.g. Journal) of Publication
•	Date Considered
	No.

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.